

The Multiple-Detector System at the beamline B2: Efficiency and Applications of the system

W.-H. Kaps¹, H.Ehrenberg², J.Ihringer¹, M.Knapp², W.Prandl¹, M.Schilling¹, T.Wroblewski³

¹Institut für Kristallographie, Universität Tübingen, Charlottenstr.33, D-72070 Tübingen
www.uni-tuebingen.de/uni/pki

²Inst. f. Materialwissenschaften, Technische Universität Darmstadt, Petersenstr. 23, D-64287 Darmstadt

³HASYLAB / DESY / Hamburg, Notkestr. 85, D-22607 Hamburg

Introduction

Synchrotron radiation sources have become indispensable for high resolution powder diffraction experiments and the number of researchers using synchrotron radiation facilities is increasing steadily. To increase the efficiency of the measurements we have designed and manufactured a multiple-detector system with four analyser units and four scintillation counters. The four analyser diffractometers are based on the Cox [1] parallel beam geometry. The efficiency of the system is determined by the net measuring time. The parameters the angular overlap and the angular width of the scans are the essential factors controlling the netmeasuring time. Different scan configurations will be discussed which provide for a maximum angular overlap of the scans (gain factors up to 3.6) [2] or a maximum width of the angular range. With interval scans reflections are detected only once by one of the four counters: so the gain factor can be increased further. The powder diffraction pattern of Si-Al₂O₃-NaCl (Fig.2) took 36h22' with a single detector. With the multiple-detector-system the measurement has done within 15h11'. Using 11 interval scans the measuring time is reduced to 5h30'. This is a gain factor over 7.

Efficiency of the system

Parameter: angular overlap and angular width

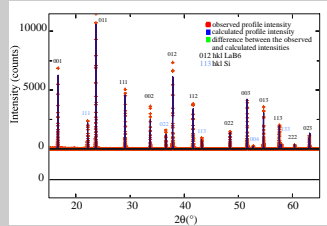


Fig.1: Rietveld refinement of LaB₆+Si pattern using a single detector. Red crosses represent the observed profile intensity, blue lines the calculated profile intensity and the difference between the observed and calculated intensities is given at the bottom (green line).

Depending on the measuring job the user can decide whether he wants a short measuring session which requires a small angular overlap, or to extend the measuring range which requires a large angular overlap. In both cases he will profit of the efficiency of the system (Tab.1).

intra angular range in (2-theta)	angular range of detector 1 in (2-theta)	angular overlap in (2-theta)	gain factor compared with single detector	gained angular range compared with single detector in %
15 - 65	15 - 29	2	3.57	-
15 - 68	15 - 32	5	2.94	5.67
15 - 73	15 - 37	10	2.27	13.79
15 - 83	15 - 47	20	1.56	26.47
15 - 93	15 - 57	30	1.19	35.89
15 - 101	15 - 65	38	1.00	41.87
15 - 103	15 - 67	40	0.96	43.18

Tab.1: Overview of the gain factors of different scan configurations. The configurations of the marked rows are shown on the right hand side.

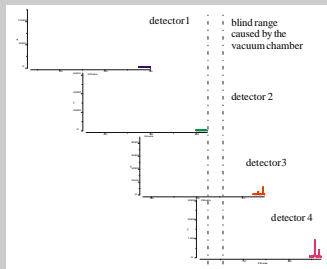
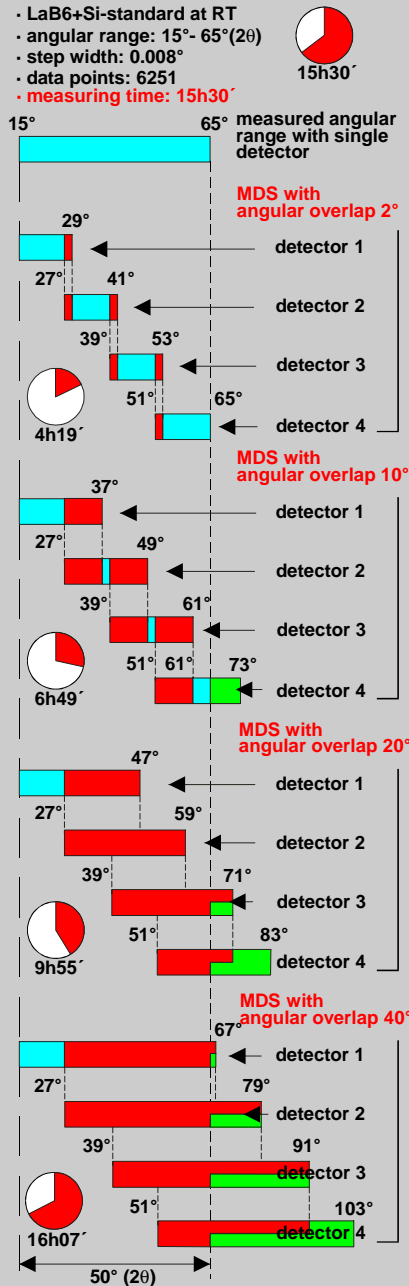


Fig.2: Powder diffraction pattern of Si-Al₂O₃-NaCl (capillary 1 mm, RT, $\lambda = 1.2067\text{\AA}$, $\Delta 2\theta$ 23.5° - 87°, step width 0.004°, net measuring time 15h11'). Scan with 11 intervals reduces the measuring time to 5h30' (with single detector 36h22'). Use the transparency to imitate the intervals and the detector window!

Legend of colours:
 blue: angular range measured by one detector
 red: angular overlap of several detectors
 green: gained angular range compared with single detector



Applications of the system

alpha-quartz measured with channel-cut analyser

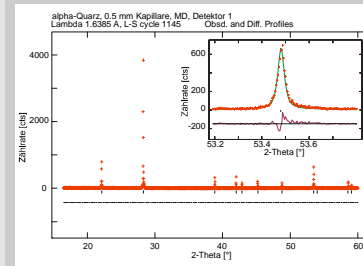


Fig.3: Powder diffraction pattern of alpha-quartz using detector 1. (capillary 0.5 mm, RT, wave-length 1.6385Å).

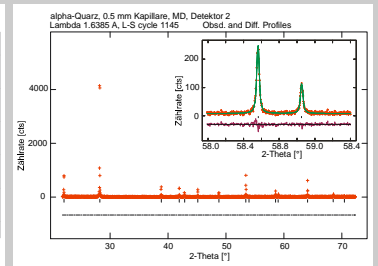


Fig.4: Powder diffraction pattern of alpha-quartz using detector 2. (capillary 0.5 mm, RT, wave-length 1.6385Å).

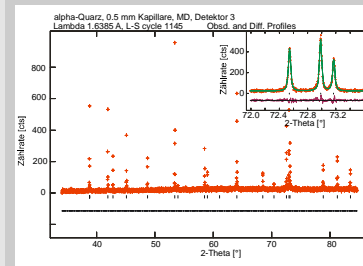


Fig.5: Powder diffraction pattern of alpha-quartz using detector 3. (capillary 0.5 mm, RT, wave-length 1.6385Å).

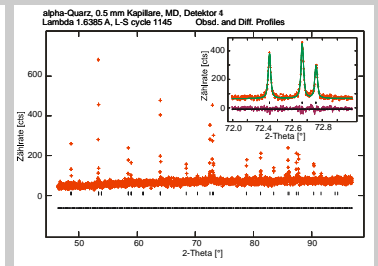


Fig.6: Powder diffraction pattern of alpha-quartz using detector 4. (capillary 0.5 mm, RT, wave-length 1.6385Å).

Tab.2: Results of the Rietveld refinement of alpha-quartz.

atom	atom parameters			detector	wRp	Rp	scale
	x	y	z				
Si	0.470659	0.0	0.333333	1	0.2906	0.1864	20.1410
sigmas	0.000287	0.0	0.0	2	0.2774	0.1653	25.7719
shft / esd	0.0	0.0	0.0	sigmas			0.169484
O	0.414298	0.266065	0.213704	3	0.2081	0.1502	29.8938
sigmas	0.000303	0.000330	0.000295	sigmas			0.301823
shft / esd	0.0	0.0	0.0	4	0.1244	0.0990	23.0161
							0.268586
				total	0.1935	0.1284	

Measurements with vacuum chamber (CeO₂), $\lambda = 2.2\text{\AA}$

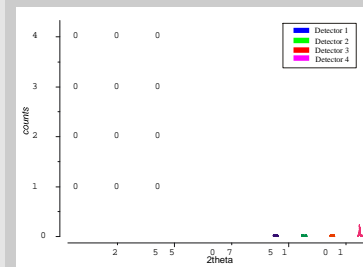


Fig.7: Powder diffraction pattern of CeO₂ (capillary 1mm, CeO, NIST 674a, RT, wavelength 2.2Å).

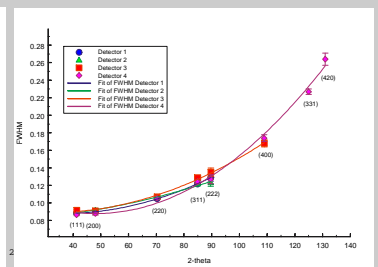


Fig.8: Variations of FWHM of CeO₂ with 2 θ for data sets obtained using four detectors.

Acknowledgement

We acknowledge financial support by the BMBF (05SM8VTA3).

Reference

- [1] D.E. Cox, J.B. Hastings, W. Thomlinson, C.T. Prewitt, Nuclear Instruments and Methods in Physics Research, 208:573-578, 1983
- [2] W.-H. Kaps, J.Ihringer, W.Prandl, M. Schilling, The Multiple-Detector System for the powder diffractometer at beamline B2 (HASYLAB), 2nd International SLS Workshop on Synchrotron Radiation, Brunnen, Schweiz, 26.10.-30.10.1999